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To: Examiner James Mitchell
FIRM: U.S. Patent and Trademark Office
FACSIMILE NO.: (703) 746-4063
FROM: John R. King, Reg. No. 34,362
OUR REFERENCE NO.: MICRON.086A
YOUR REFERENCE NO.: U.S. Application No. 09/389,720, filed September 3, 1999
TOTAL NUMBER OF PAGES: 5 (INCLUDING COVER SHEET)
OPERATOR: (Ms.) Sam Bethune, Assistant to John R. King
DATE: March 14, 2002

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MICRON.086A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Dickey)	Group Art Unit 2822
Appl. No.	:	09/389,720)	CERTIFICATE OF FAX TRANSMISSION
Filed	:	September 3, 1999)	I hereby certify that this correspondence and
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)	<i>John R. King</i>
)	John R. King, Reg. No. 34,362

#10/c
Amend
J. Mitchell
7/30/02

SUPPLEMENTAL AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Examiner Interview conducted on March 13, 2002, Applicant respectfully submits the following amendments and remarks in connection with the above-captioned application.

AMENDMENT

Please amend Claim 20 as follows:

20. (Twice Amended) An assembly, comprising:

a film including a plurality of substrate units with each of said plurality of substrate units being adapted to electrically interface with a corresponding die, each one of said plurality of substrate units being generally defined on said film between a pair of flanking slots wherein each flanking slot in the film extends such that it is in contact with a side rail of a carrier and that said slot is placed only in the area where the assembly is to be cut, and that said carrier is in mechanical communication with said film for providing enhanced rigidity to said film by being sized and configured to add material at selected regions of said film.